



## **PATENT APPLICATION**

**RESPONSE UNDER 37 CFR §1.116** EXPEDITED PROCEDURE **TECHNOLOGY CENTER ART UNIT 2653** 

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re the Application of

Ikuhito ONODERA

Group Art Unit: 2653

Application No.: 10/076,653

Examiner:

C. MAGEE

Filed: February 19, 2002

Docket No.: 111984

For:

METHOD FOR FABRICATING A THIN FILM MAGNETIC HEAD AND WAFER

**STRUCTURE** 

## AMENDMENT AFTER FINAL REJECTION UNDER 37 CFR §1.116

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In reply to the July 14, 2005, Office Action, please consider the following:

Amendments to the Specification;

Remarks.